Notice of References Cited Application/Control No. 10/776,675 Examiner Erick Glass Applicant(s)/Patent Under Reexamination HAAG ET AL. Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-2002/0074959	06-2002	Van Wiemeersch, John Robert	318/445
	В	US-5,563,483	10-1996	Kowall et al.	318/283
	ပ	US-6,676,186	01-2004	Greif, Thomas	296/50
	D	US-5,982,126	11-1999	Hellinga et al.	318/468
	Ε	US-5,396,158	03-1995	Long et al.	318/282
	F	US-2005/0151495	07-2005	Miyauchi, Kazutoshi	318/469
	G	US-			
	Н	US-			
	ı	US-			
	J	US-			
	К	US-			
	L	US-			
\Box	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	σ					
	R					
	S					
	Т					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
	w	
	x	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.